504381059 05/23/2017

PATENT ASSIGNMENT COVER SHEET

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SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
ALEXANDER VIKTOROVICH BOLOTNIKOV	05/22/2017
PETER ALMERN LOSEE	05/22/2017

RECEIVING PARTY DATA

Name:	General Electric Company
Street Address:	1 River Road
City:	Schenectady
State/Country:	NEW YORK
Postal Code:	12345

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	15601754

CORRESPONDENCE DATA

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Correspondence will be sent to the e-mail address first; if that is unsuccessful, it will be sent

using a fax number, if provided; if that is unsuccessful, it will be sent via US Mail.

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Email: gpo.mail@ge.com, rariden@fyiplaw.com, robinson@fyiplaw.com

Correspondent Name: GENERAL ELECTRIC COMPANY GLOBAL RESEARCH

Address Line 1: ONE RESEARCH CIRCLE

Address Line 2: BUILDING K1-3A59

Address Line 4: NISKAYUNA, NEW YORK 12309

ATTORNEY DOCKET NUMBER:	MBER: 283394-1 (GERD:1298)	
NAME OF SUBMITTER:	JOHN M. RARIDEN	
SIGNATURE:	/John Rariden/	
DATE SIGNED:	05/23/2017	
	This document serves as an Oath/Declaration (37 CFR 1.63).	

Total Attachments: 4

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PATENT REEL: 042483 FRAME: 0411 source=283394_1_US_Assignment_23MAY2017#page4.tif

PATENT REEL: 042483 FRAME: 0412 ELECTRIC FIELD SHIELDING IN SILICON CARBIDE METAL-OXIDE-SEMICONDUCTOR (MOS) DEVICES HAVING AN OPTIMIZATION LAYER

COMBINED DECLARATION AND GLOBAL ASSIGNMENT FOR UTILITY OR DESIGN PATENT APPLICATION

As the below named inventor(s), I/we hereby declare that:

This declaration and assignment are directed to:

ELECTRIC FIELD SHIELDING IN SILICON CARBIDE METAL-OXIDE-SEMICONDUCTOR (MOS) DEVICES HAVING AN OPTIMIZATION LAYER

	the specification of which	າ is attached here	eto OR		
\boxtimes	United States application	n or PCT internat	ional application num	nber	
	15/601,754	filed on	May 22, 2017	, as	
	amended on [date] (if ap	plicable).			
	(We hereby authorize and	request the Comp	oany or its delegated a	attorneys or agents	to
	insert above the application	number and filing	date of the application	n when known.)	

The above-identified application was made or authorized to be made by us.

We believe that we are original joint inventors of a claimed invention in the application.

We hereby acknowledge that any willful false statement made in this declaration is punishable under 18 USC § 1001 by fine or imprisonment of not more than five (5) years, or both.

We acknowledge the duty to disclose information which is material to the patentability of this application as defined in 37 CFR § 1.56, including, for continuation-in-part applications, material information which became available between the filing date of the prior application and the filing date of the continuation-in-part application.

In accordance with our obligation(s) under an Employee Innovation and Proprietary Information Agreement or (as applicable) arising out of other agreements (such as, but not limited to, the Services Agreement between General Electric Company, a New York corporation, and our employers), and/or for other good and valuable consideration of which we acknowledge receipt, we,

Inventor First Name	Inventor Middle Name	Inventor Last Name		Residence Town	Residence State	Residence Country
Alexander	Viktorovich	Bolotnikov	of	Niskayuna	NY	US
Peter	Almern	Losee	of	Clifton Park	NY	US

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PATENT REEL: 042483 FRAME: 0413 GE Docket No. 283394-1

ELECTRIC FIELD SHIELDING IN SILICON CARBIDE METAL-OXIDE-SEMICONDUCTOR (MOS) DEVICES HAVING AN OPTIMIZATION LAYER

hereby sell and assign to:

Name of Company:	General Electric Company	
Entity Type:	New York corporation	
Address:	1 River Road, Schenectady, New York 12345 USA	

herein referred to as "Company", its successors and assigns our entire respective rights, titles and interests in and to the invention and improvements made and conceived by us described in the application(s) listed above and in the following table:

Country of Filing	Type of Filing	Application Number	Filing Date	Title

(We hereby authorize and request the Company or its delegated attorneys or agents to insert above the application number and filing date of the application(s) when known.)

and any and all applications for patent and patents therefrom in any and all countries, including all divisions, continuations, reexaminations and reissues thereof, and all rights of priority resulting from the filing of the application(s), and authorize and request any official whose duty it is to issue patents, to issue any patent on the inventions and improvements resulting therefrom to the Company, or its successors or assigns and agree that on request and without further consideration, we will communicate to the Company or its representatives or nominees any facts known to us respecting the inventions and improvements and testify in any legal proceeding, sign all lawful papers, execute all divisional, continuation, reexamination and reissue applications, make all rightful oaths and generally do everything possible to aid the Company, its successors, assigns, and nominees to obtain and enforce proper patent protection for the invention and its improvements in all countries.

Remuneration claims of the inventor(s)/assignor(s) potentially arising from German Law on Employee Inventions, or any other respective country law, remain unaffected by this assignment.

OPTIMIZATION LAYER	
INVENTOR 1	
Signature: Alexander Viktorovich Bolotnikov	Date: <u>5/22/22/9</u>
Witnessed by: Signature	Date: <u>5/22/ 2017</u>
Peter Deeb	
Printed Name of Witness	
Witnessed by: <u>Clusty L. Clipe D.L.</u> Signature	Date: <u>5 /22/20/7</u>
<u> Aris to pher Colla zo - Davila</u> Printed Name of Witness	
SECTION BELOW IS FOR USE ONLY IF SIGNII	NG IN PRESENCE OF A NOTARY
Dat Alexander Viktorovich Bolotnikov	e:
STATE OF	
SS.	
COUNTY OF	
This day of, 2017 be Alexander Viktorovich Bolotnikov, to me persons foregoing assignment, who acknowledged to me the free will for the purposes therein set forth.	
Seal	(Notone Disklin)
	(Notary Public)

ELECTRIC FIELD SHIELDING IN SILICON CARBIDE METAL-OXIDE-SEMICONDUCTOR (MOS) DEVICES HAVING AN

GE Docket No. 283394-1

GE Docket No. 283394-1 ELECTRIC FIELD SHIELDING IN SILICON CARBIDE METAL OPTIMIZATION LAYER INVENTOR 2	-OXIDE-SEMICONDUCTOR (MOS) DEVICES HAVING AN
Signature: Peter Almern Losee	
Witnessed by: Signature	Date: <u>5/22/2017</u>
Pejer Decb Printed Name of Witness	
Witnessed by: <u>(kritata Algo-Dita</u> Signature	Date: <u>5/22/20/7</u>
Christopher Collazo - Davila Printed Name of Witness	
SECTION BELOW IS FOR USE ONLY IF SIG	NING IN PRESENCE OF A NOTARY
Peter Almern Losee	Date:
STATE OF	
COUNTY OF	
This day of, 2017 Peter Almern Losee, to me personally known assignment, who acknowledged to me that he/s the purposes therein set forth.	before me personally came the above-named as the individual who executed the foregoing the executed the same of his/her own free will for
Seal	/Notan/ Public)

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